

# 14 10-26-89  
Gp 2814 PR  
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of

MIZUHARA et al.

Serial No.: 09/037,674

Filed: March 9, 1998

Atty. File No.: 2933SE-11-CIP-2

For: "SEMICONDUCTOR DEVICES  
PASSIVATION FILM"

Assistant Commissioner for Patents  
Washington, D.C. 20231

Group Art Unit: 2814

Examiner: To be assigned

SUPPLEMENTAL INFORMATION  
DISCLOSURE STATEMENT

CERTIFICATE OF MAILING

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING  
DEPOSITED WITH THE UNITED STATES POSTAL SERVICE  
AS FIRST CLASS MAIL IN AN ENVELOPE ADDRESSED TO  
THE ASSISTANT COMMISSIONER OF PATENTS,  
WASHINGTON, DC 20231 ON May 11, 1999.

SHERIDAN ROSS P.C.

BY: *Aimee Shuck*

Dear Sir:

Pursuant to Applicants' duty of disclosure under 37 CFR § 1.56, Applicants hereby submit this Supplemental Information Disclosure Statement with a copy of the documents identified on the enclosed PTO Form 1449, although Applicants do not admit that any of such documents, alone or in any combination, is considered to be material to patentability as defined in 37 CFR § 1.56(b). Moreover, the inclusion of these documents is not to be construed as an admission by Applicants that each such document is prior art as to the above-identified patent application.

Respectfully submitted,

SHERIDAN ROSS P.C.

By: *Joseph E. Kovarik*

Joseph E. Kovarik  
Registration No. 33,005  
1700 Lincoln Street, Suite 3500  
Denver, Colorado 80203  
(303) 863-9700

RECEIVED

MAY 19 1999

TECHNOLOGY CENTER 2800

Date: 5/11/99